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## BIB DATA SHEET

CONFIRMATION NO. 7353

SERIAL NUMBER	FILING or 371(c) DATE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO.
10/559,135	02/11/2008	451	3723	2005-1890A
<b>RULE</b>				
<b>APPLICANTS</b> Tetsuji Togawa, Tokyo, JAPAN; Koichi Fukaya, Tokyo, JAPAN; Mitsuo Tada, Tokyo, JAPAN; Taro Takahashi, Tokyo, JAPAN; Yasunari Suto, Tokyo, JAPAN;				
<b>** CONTINUING DATA *****</b> This application is a 371 of PCT/JP2004/008855 06/17/2004				
<b>** FOREIGN APPLICATIONS *****</b> JAPAN 2003174144 06/18/2003				
<b>** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **</b> 03/03/2008				
Foreign Priority claimed	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No	<input type="checkbox"/> Met after Allowance	<b>STATE OR COUNTRY</b>	<b>SHEETS DRAWINGS</b>
35 USC 119(a-d) conditions met	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No	Initials	JAPAN	23
Verified and Acknowledged	/EILEEN P MORGAN/ Examiner's Signature			<b>TOTAL CLAIMS</b>
				18
				<b>INDEPENDENT CLAIMS</b>
				6
<b>ADDRESS</b> WENDEROTH, LIND & PONACK, L.L.P. 1030 15th Street, N.W., Suite 400 East Washington, DC 20005-1503 UNITED STATES				
<b>TITLE</b> Substrate Polishing Apparatus And Substrate Polishing Method				
<b>FILING FEE RECEIVED</b> 1650	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees		
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